INTERNATIONAL GEMOLOGICAL INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

October 5, 2026

IGI Report Number	LG842638737
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ANTIQUE CUSHION CUT
Measurements	8.77 X 7.09 X 4.59 MM

GRADING RESULTS

Carat Weight	2.18 CARATS
Color Grade	D
Clarity Grade	VVS 2

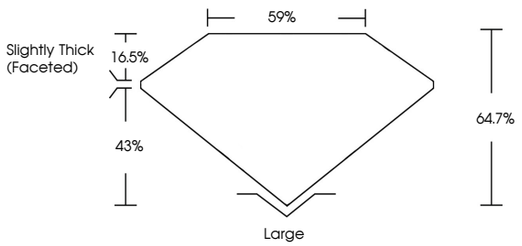
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG842638737

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG842638737
Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

© IGI 2020, International Gemological Institute

FD - 10 20

THIS DOCUMENT WAS PRODUCED WITH THE FOLLOWING SECURITY MEASURES: SPECIAL DOCUMENT PAPER, INK SCREENS, WATERMARK BACKGROUND DESIGNS, HOLOGRAM AND OTHER SECURITY FEATURES NOT LISTED AND DO EXCEED DOCUMENT SECURITY INDUSTRY GUIDELINES.

www.igi.org

LABORATORY GROWN DIAMOND REPORT

October 5, 2026

IGI Report Number	LG842638737
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ANTIQUE CUSHION CUT
Measurements	8.77 X 7.09 X 4.59 MM

GRADING RESULTS

Carat Weight	2.18 CARATS
Color Grade	D
Clarity Grade	VVS 2

59%
Slightly Thick (Faceted)
16.5%
43%
64.7%
Large

ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG842638737

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

IGI

October 5, 2026
IGI Report No LG842638737
ANTIQUE CUSHION CUT
8.77 X 7.09 X 4.59 MM
Carat Weight 2.18 CARATS
Color Grade D
Clarity Grade VVS 2
Depth 64.7%
Table 59%
Girdle Slightly Thick (Faceted)
Culet Large
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) LG842638737
Comments:
This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa